

AMENDMENTS TO THE CLAIMS

1. (Currently Amended) A semiconductor device comprising:
~~a dummy pattern for alleviating for a difference in density in an arranged pattern;~~
a plurality of wiring layers vertically overlapping with each other, including a first layer
and a second layer; a power supply wire; and a ground wire;
wherein said first layer and said second layer include a dummy pattern, each arranged to
alleviate for a difference in density in a planar layout of wiring pattern in a same layer,
said dummy pattern of said first layer and said dummy pattern of said second layer are
electrically connected with each other and further is electrically connected to a reference wire
which is either said power-supply wire or said ground wire.

2. (Currently Amended) The semiconductor device according to claim 1, wherein
electrical connection between said dummy pattern and said reference wire is made through paths
formed by a process including a first step of:
setting all ~~said~~ dummy patterns as unconnected dummy patterns, and a second step of:
retrieving any said unconnected dummy patterns that overlap each other and are adjacent
to each other in an up and down direction with not less than a predetermined distance using a
target wire which is either said reference wire or wires having the same electrical potential as
said reference wire as the starting point,

in the case when, as a result of said retrieval, any of such said unconnected dummy
patterns are detected, recognizing these as adjacent dummy patterns and providing an interlayer
connection between said target wire and said adjacent dummy patterns, as well as changing the

setting of said adjacent dummy patterns as non-unconnected dummy patterns with said adjacent dummy patterns being set as those having the same electric potential as said target wire, recursively repeating said second step with respect to all said reference wires and those wires having the same electrical potential as said reference wire, in place of said reference wire, with the other of said power-supply wire and said ground wire being newly used as a reference wire, recursively repeating said second step with respect to all said reference wires and those wires having the same electrical potential as said reference wire.

Claims 3-4 (Withdrawn)

5. (Original) A designing device of a semiconductor device comprising:
a dummy pattern generation means for generating dummy patterns so as to eliminate a difference in density in a wiring pattern based upon wiring layout information that has been provided;
an unconnected dummy pattern setting means for setting all said dummy patterns as unconnected dummy patterns so as to electrically connect said dummy patterns and said reference wire with one of a power-supply wire and a ground wire being used as a reference wire based upon layout information of a power-supply wire and a ground wire that has been supplied; a first recursive process executing means which retrieves any said unconnected dummy patterns that overlap each other and are adjacent to each other in an up and down direction with not less than a predetermined distance using a target wire which is either said reference wire or

wires having the same electrical potential as said reference wire as the starting point for a dummy pattern connection process,

which in said case when, as a result of said retrieval, any of such unconnected dummy patterns are detected, recognizes these as adjacent dummy patterns and provides an interlayer connection between said target wire and said adjacent dummy patterns, as well as changing the setting of said adjacent dummy patterns as non-unconnected dummy patterns with said adjacent dummy patterns being set as those having said same electric potential as said target wire,

which recursively repeats said sequence of jobs with respect to all said reference wire and those wires having the same electrical potential as said reference wire, and

a second recursive process job executing means which, in place of said reference wire, with the other of said power-supply wire and said ground wire being newly used as said reference wire, recursively repeats said dummy pattern connection process with respect to all said reference wires and those wires having said same electrical potential as said reference wire.